

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	(conduction adj layer) with coupled with etch with expose with dissipate with charge with buildup.clms.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/28 07:43
S1	8	("20020104821" "5129981" "5865938" "6333246").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/07 18:08
S2	127	(etch or etching) and (charge with buildup) and ((conductive or conduction or metal) with (dissipate or reduce))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/07 18:13
S3	24	S2 and ((conductive or conduction or metal) with aluminum)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/07 18:13
S4	16	(etch or etching) with (charge with buildup) and ((conductive or conduction or metal) with (dissipate or reduce))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/07 18:13
S5	5	S4 and ((conductive or conduction or metal) with aluminum)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/07 18:13
S6	854	257/510.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/21 18:14